



**CMA Industrial Development Foundation Limited**

香港中華廠商聯合會工業發展基金有限公司

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Scope of Accreditation  
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**TYPE OF INSPECTION BODY**

檢驗機構類別

: A : Provides 'third party' inspection service to the public  
向公眾提供「第三方」檢驗服務

**ACCREDITED INSPECTION  
FIELD**

認可檢驗領域

: Indoor Air Quality Inspection 室內空氣質素檢驗

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**Indoor Air Quality Inspection 室內空氣質素檢驗**

ITEM INSPECTED 檢驗項目	SPECIFIC PROPERTY OR CHARACTERISTIC INSPECTED 特定檢驗特性或特徵	SPECIFICATION, INSPECTION METHOD OR STANDARD 規範、檢驗方法或標準
Indoor Air Quality	On-site measurement of : - Carbon Dioxide  - Carbon Monoxide  - Formaldehyde  - Nitrogen Dioxide  - Ozone  - Radon  - Respirable Suspended Particulate  - Total Volatile Organic Compound  On-site sampling of : - Airborne Bacteria  Walkthrough Inspection  Mould  IAQ Compliance Assessment	A Guide on Indoor Air Quality Certification Scheme for Offices and Public Places, The Government of the HKSAR, Indoor Air Quality Management Group, January 2019  Annex 4 (a), as documented in SOP-ENV-IAQ-4 (Non-dispersive infrared NDIR)  Annex 4 (a), as documented in SOP-ENV-IAQ-5 (Electrochemical sensor)  Annex 4 (c), as documented in SOP-ENV-IAQ-15 (Photoelectric photometry detector) (Gas sensitive electrochemical sensor)  Annex 4 (d), as documented in SOP-ENV-IAQ-16 (Electrochemical Sensor)  Annex 4 (e), as documented in SOP-ENV-IAQ-1 (Gas sensitive semiconductor) (Gas sensitive electrochemical sensor)  Annex 4 (b), as documented in SOP-ENV-IAQ-9 (Electrostatic collection of alpha-emitters with spectral analysis) (Diffused junction photodiode)  Annex 4 (f), as documented in SOP-ENV-IAQ-3 (Light scattering laser diode)  Annex 4 (g), as documented in SOP-ENV-IAQ-8 (Photo-ionization sensor)  Annex 4 (h), as documented in SOP-ENV-IAQ-12 (Single-stage Impactor)  Clauses 13 and 14  Clause 20  Clauses 16 to 19 and Clauses 21 to 40